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<b>SERIAL NUMBER</b> 10/539,883	<b>FILING OR 371(c) DATE</b> 06/17/2005 <b>RULE</b>	<b>CLASS</b> 349	<b>GROUP ART UNIT</b> 2871	<b>ATTORNEY DOCKET NO.</b> DE1642
<b>APPLICANTS</b> Jaehwan Eun, Jeonju-si Jeonrabuk-do, KOREA, REPUBLIC OF; Sang-Goo Lee, Siheung-si, Kyungki-do, KOREA, REPUBLIC OF; Hyeongjoon Kim, Seongnam-si, Kyungki-do, KOREA, REPUBLIC OF; Minchan Kim, Jeju-si, Jeju-do, KOREA, REPUBLIC OF;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/KR03/01391 07/14/2003				
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 1020020080745 12/17/2002 REPUBLIC OF KOREA 1020030012846 02/28/2003				
** SMALL ENTITY **				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 4	<b>TOTAL CLAIMS</b> 16
				<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> 1109				
<b>TITLE</b> Method for preparation of ferroelectric single crystal film structure using deposition method				
<b>FILING FEE RECEIVED</b> 630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	